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PATENT
Customer No. 22,852
Attorney Docket No. 7553.0019-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Chishio KOSHIMIZU et al.)	Group Art Unit: 1763
)	
Application No.: 10/675,966)	Examiner: P. Hassanzadeh
)	
Filed: October 2, 2003)	
)	
For: PLASMA PROCESSING)	Confirmation No. 6290
APPARATUS AND PLASMA)	
PROCESSING METHOD)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed July 2, 2004, the period for response having been extended to January 3, 2005 (January 2, 2005 being a Saturday) by a Petition for Extension of Time - Three Months and appropriate fee payment, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.